



1

MEMC 98-5751 (2358.4)  
PATENT

13

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Mutti et al.

Serial No. 10/008,812

Filed November 13, 2001

For METHOD FOR CONTROLLING GROWTH OF A SILICON CRYSTAL TO MINIMIZE  
GROWTH RATE AND DIAMETER DEVIATIONS

November 20, 2003

**LETTER TO THE OFFICIAL DRAFTSMAN**

TO THE COMMISSIONER FOR PATENTS,

SIR:

Submitted herewith are five (5) sheets of formal drawings to replace the drawings now on file.

The Commissioner is hereby authorized to charge any fees that may be required during the entire pendency of this application to Deposit Account No. 19-1345.

Respectfully submitted,

Robert M. Bain, Reg. No. 36,736  
SENNIGER, POWERS, LEAVITT & ROEDEL  
One Metropolitan Square, 16th Floor  
St. Louis, Missouri 63102  
314/231-5400